

FIG.1

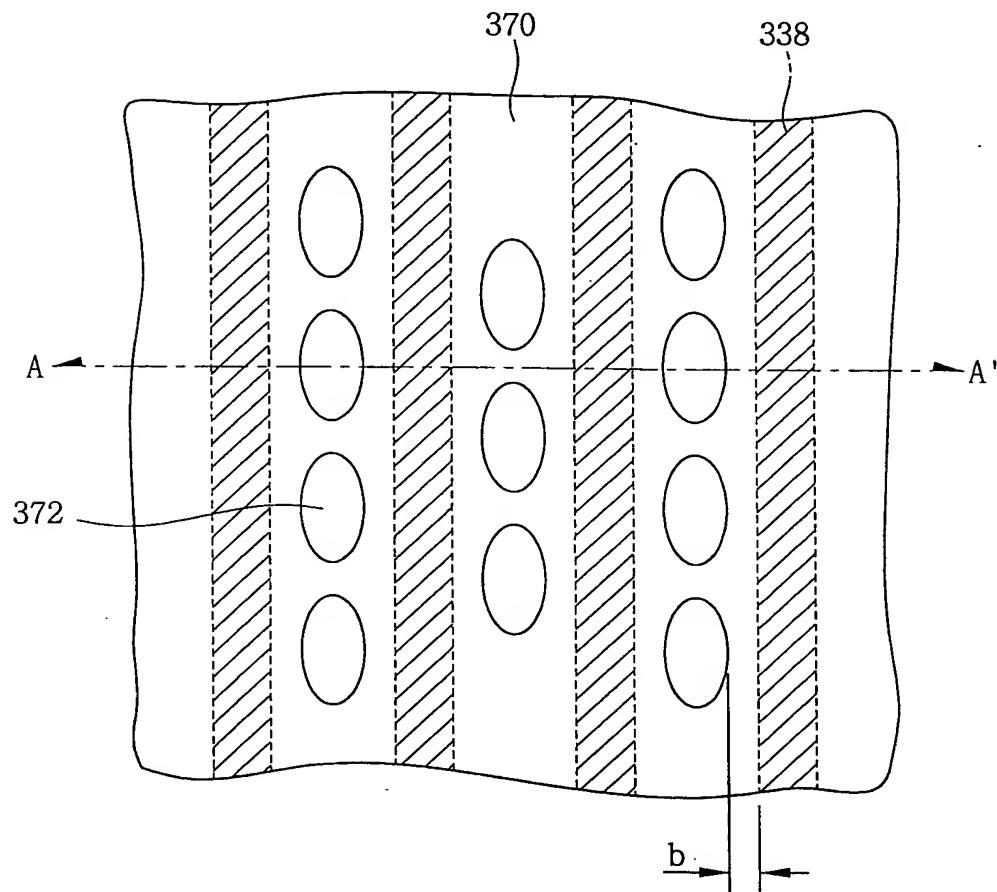
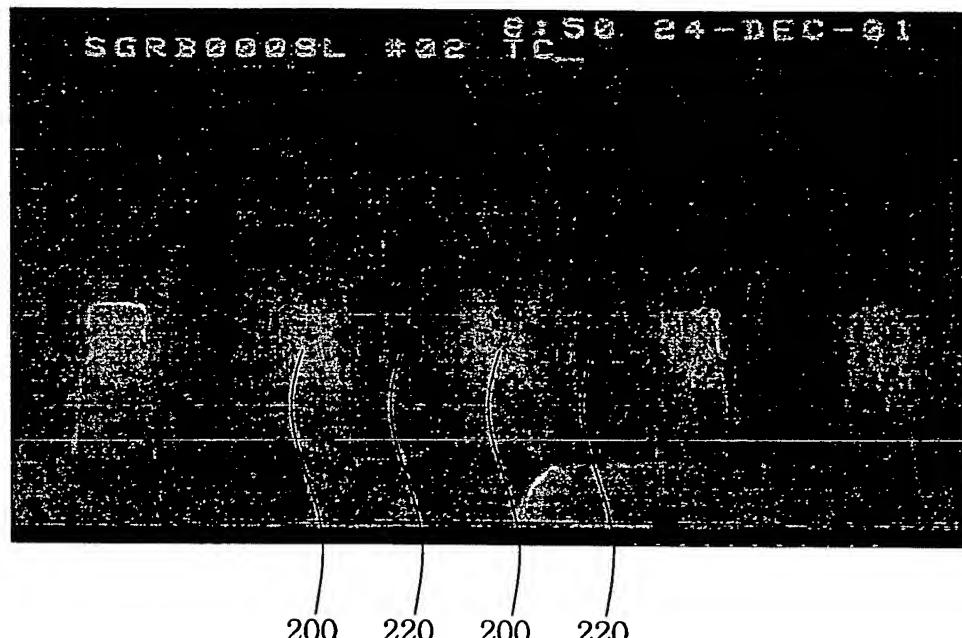


FIG.2  
(PRIOR ART)



BEST AVAILABLE COPY

FIG.3A

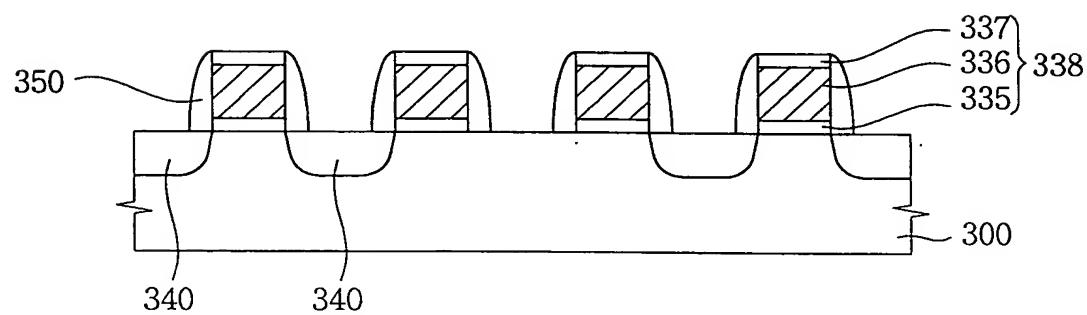


FIG.3B

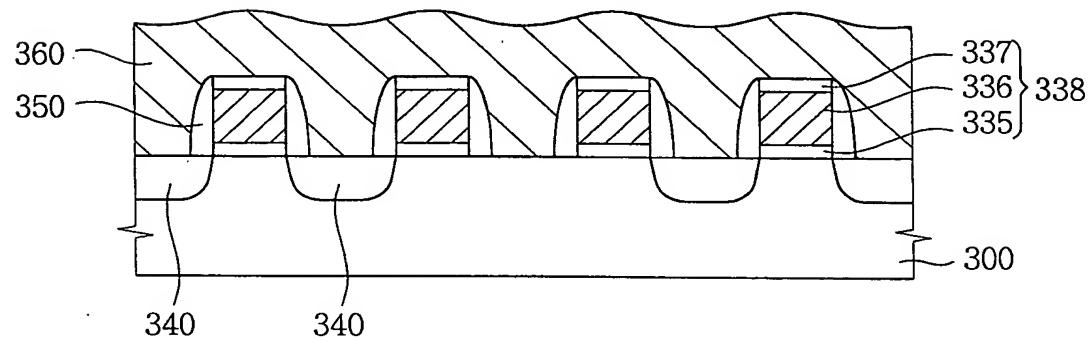


FIG.3C

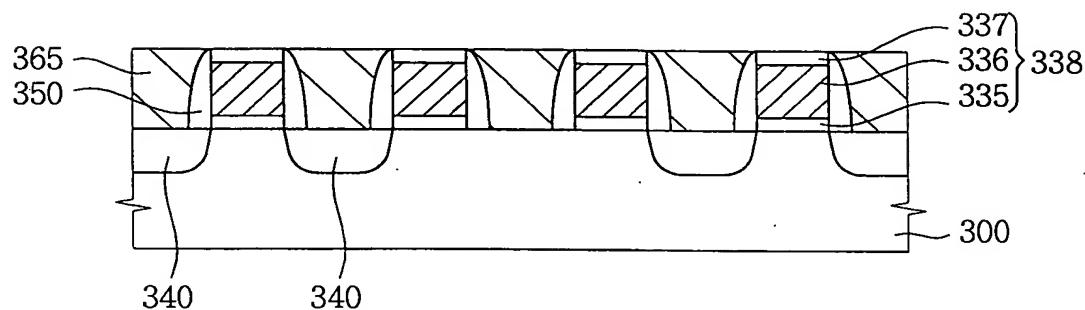


FIG.3D

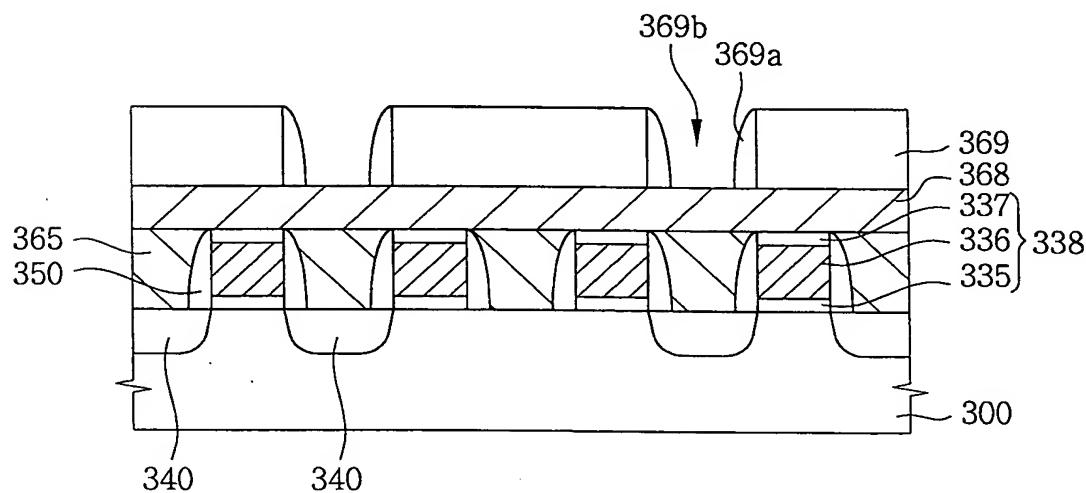


FIG.3E

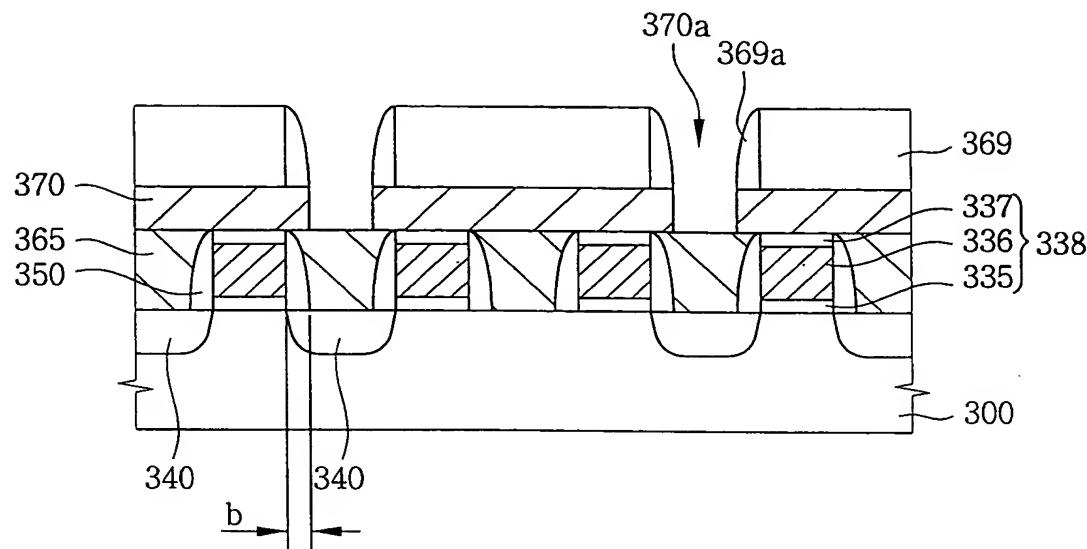


FIG.3F

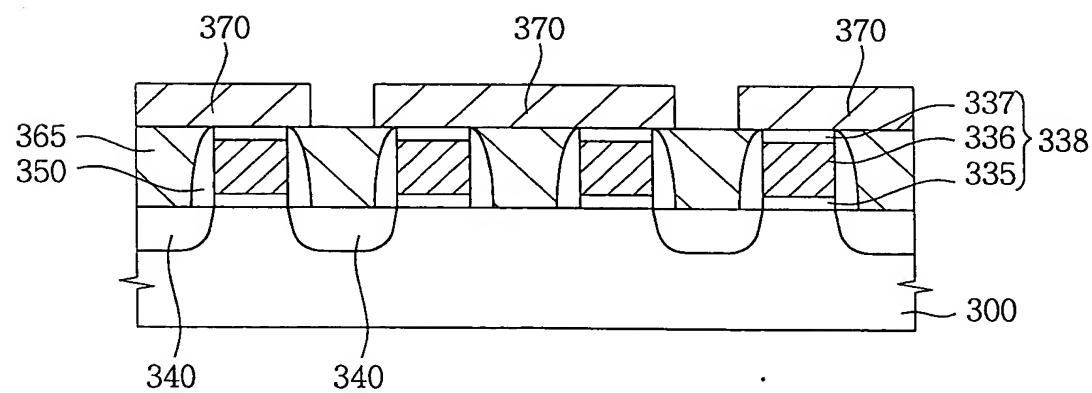


FIG. 3G

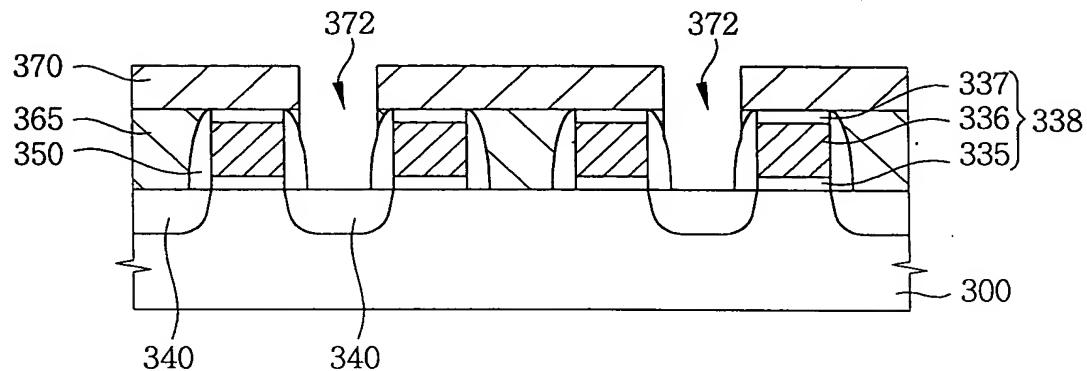


FIG. 3H

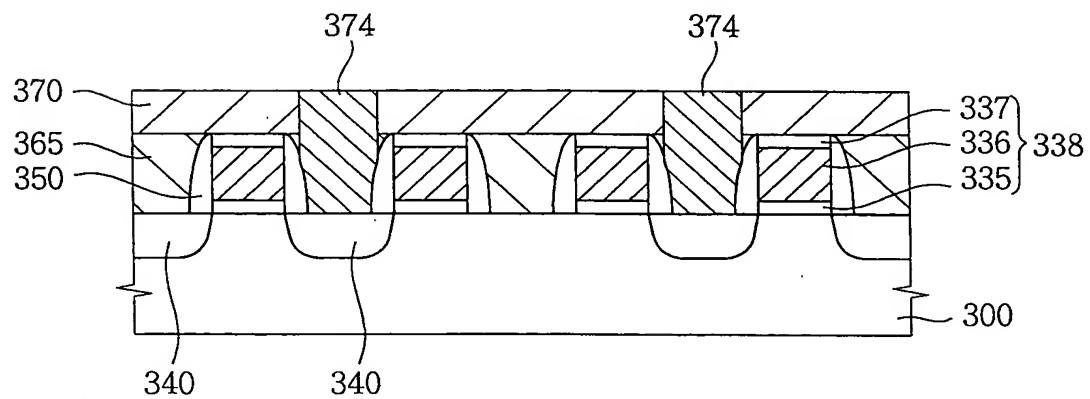


FIG. 4

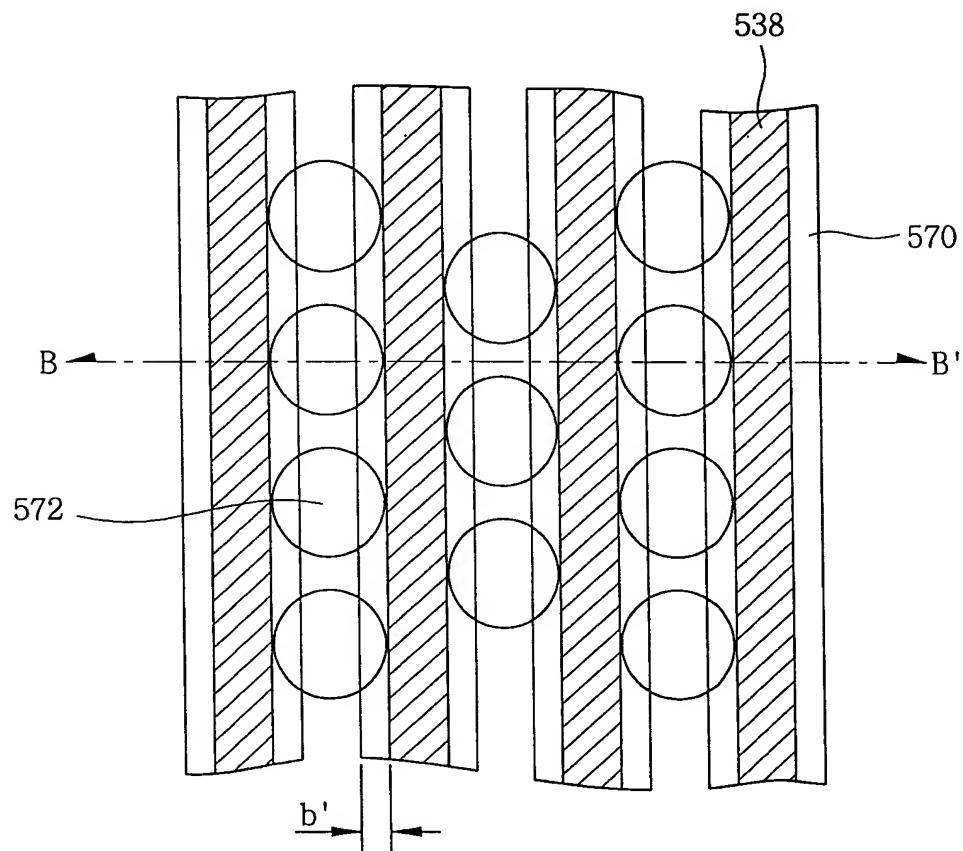


FIG.5A

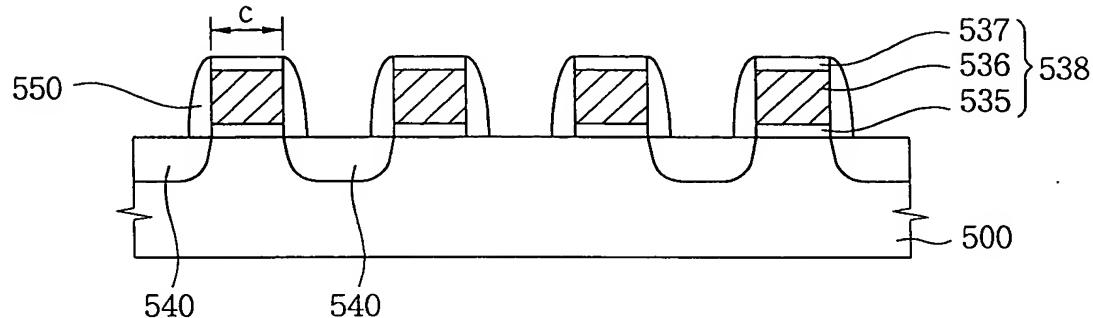


FIG.5B

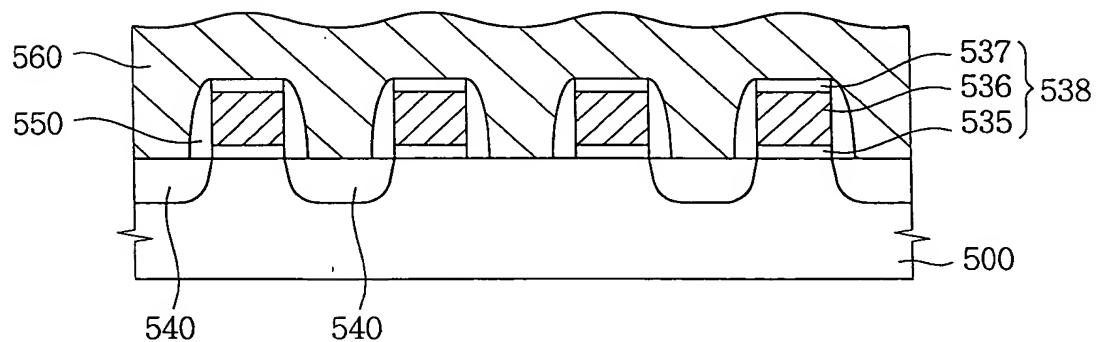


FIG.5C

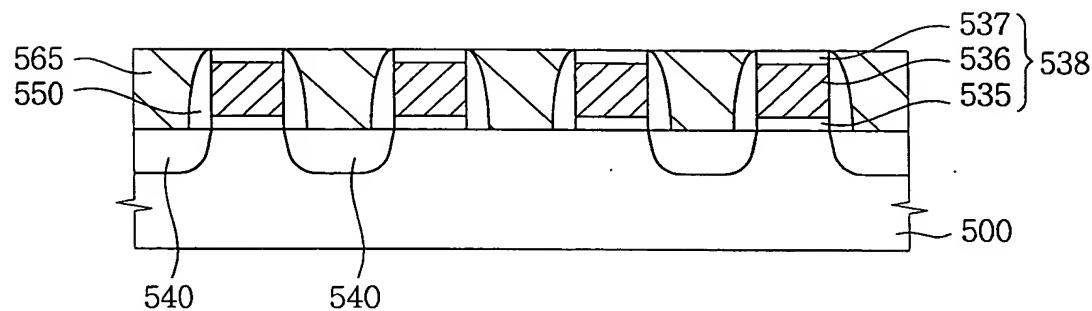


FIG.5D

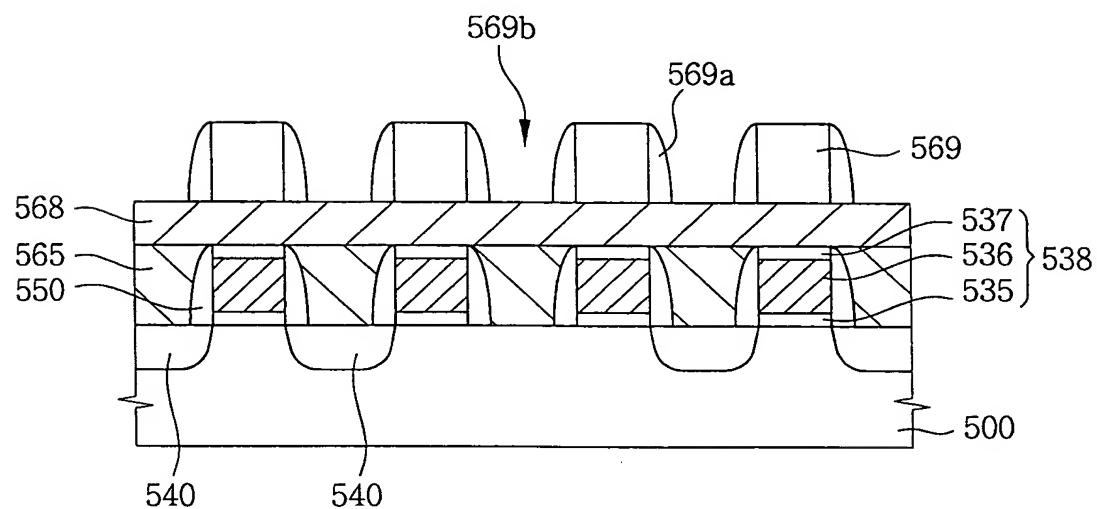


FIG.5E

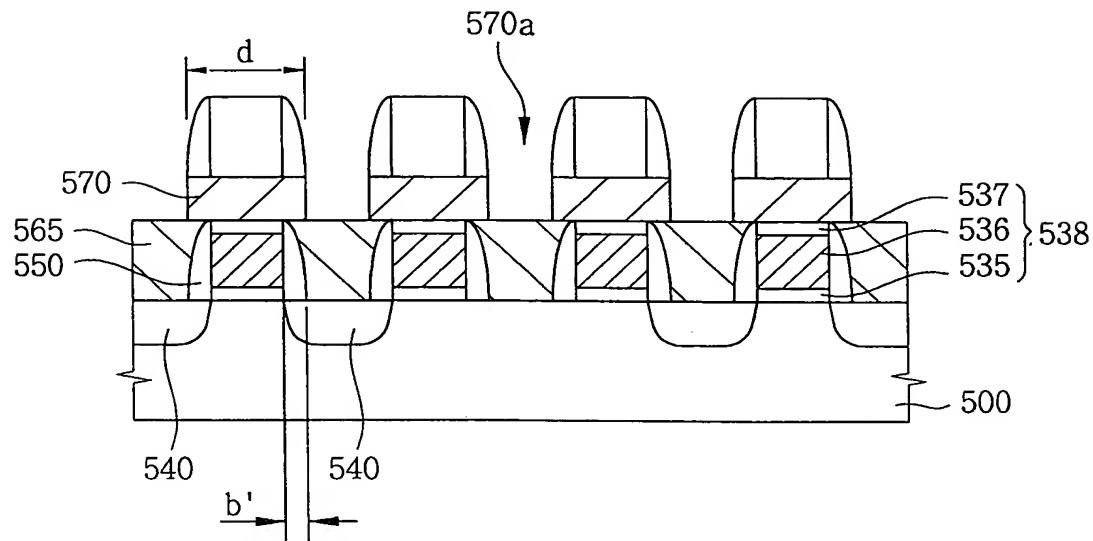


FIG.5F

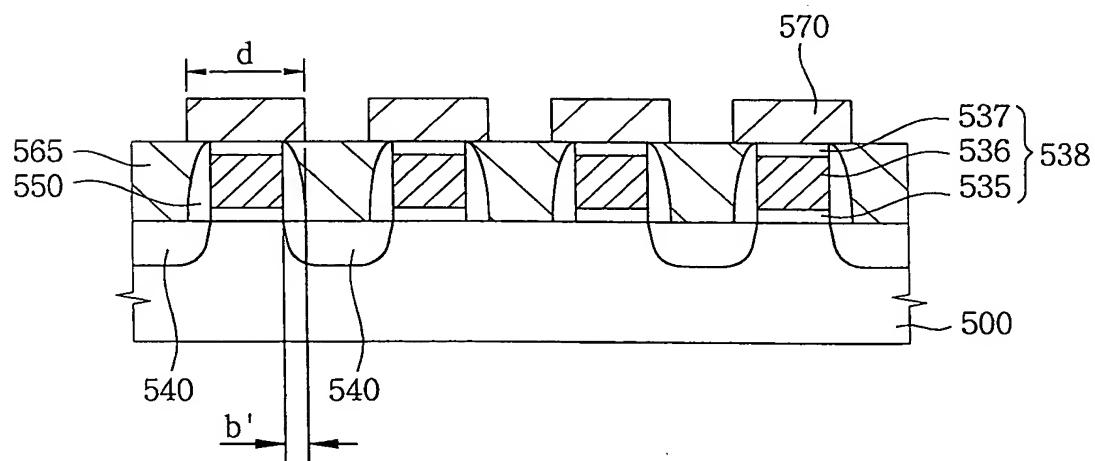


FIG.5G

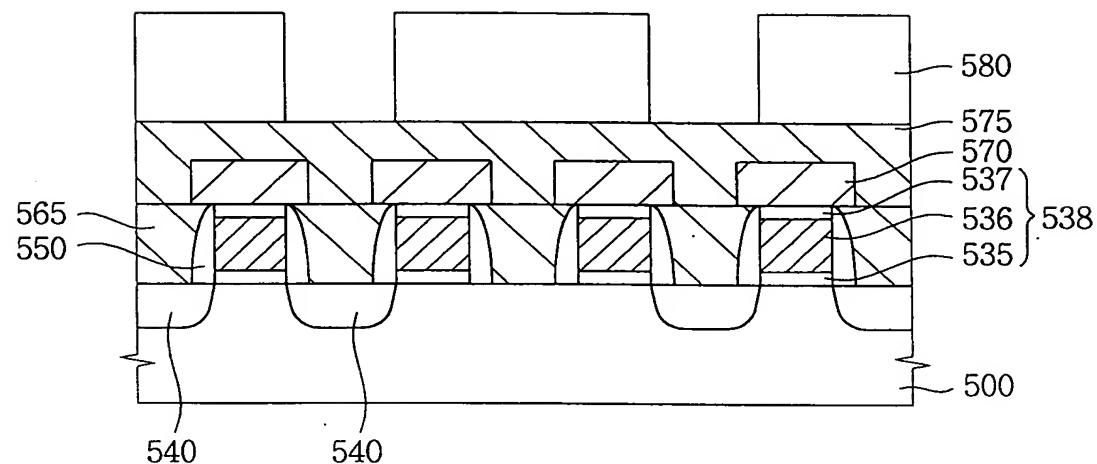


FIG.5H

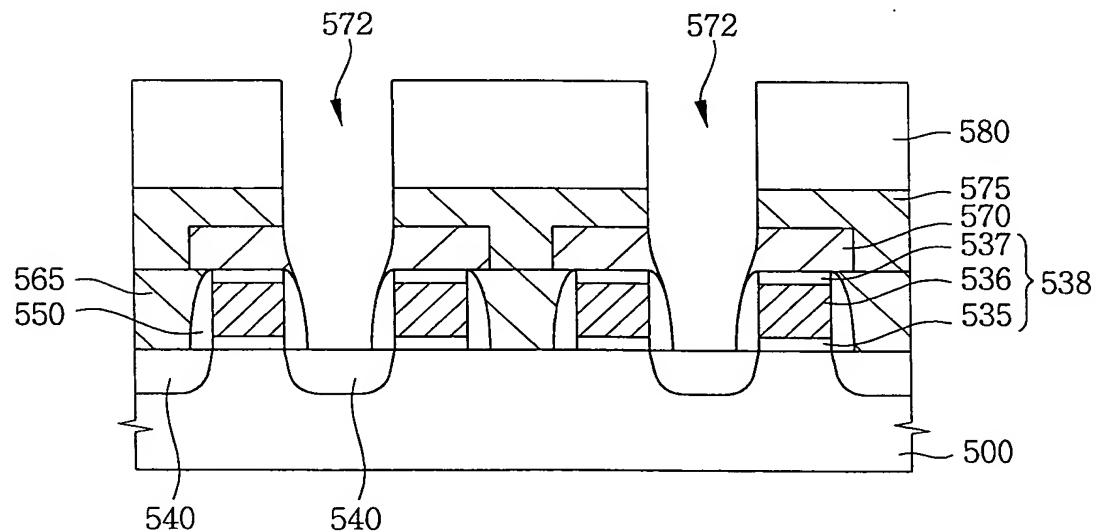


FIG.5I

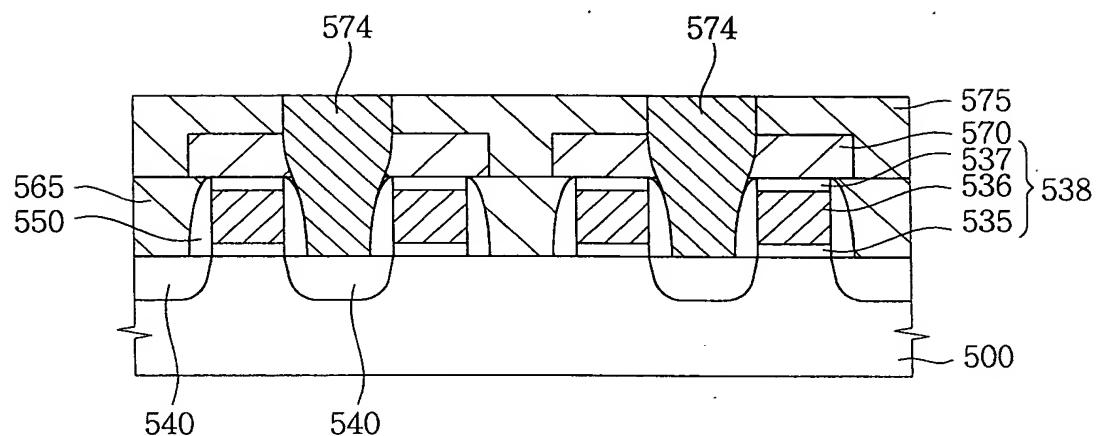


FIG. 6A

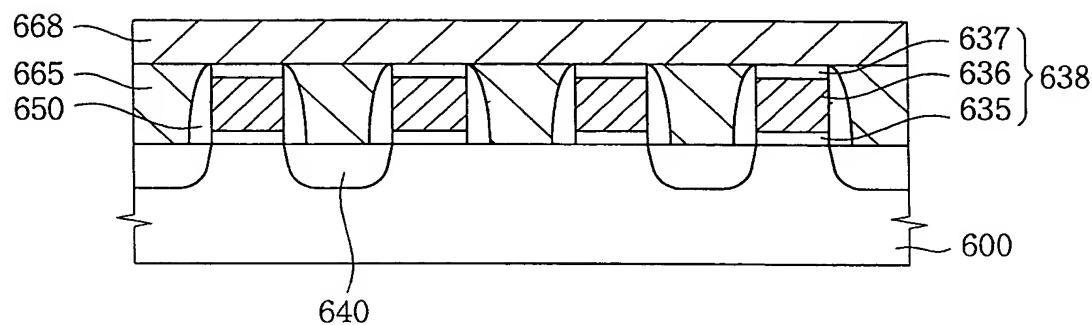


FIG. 6B

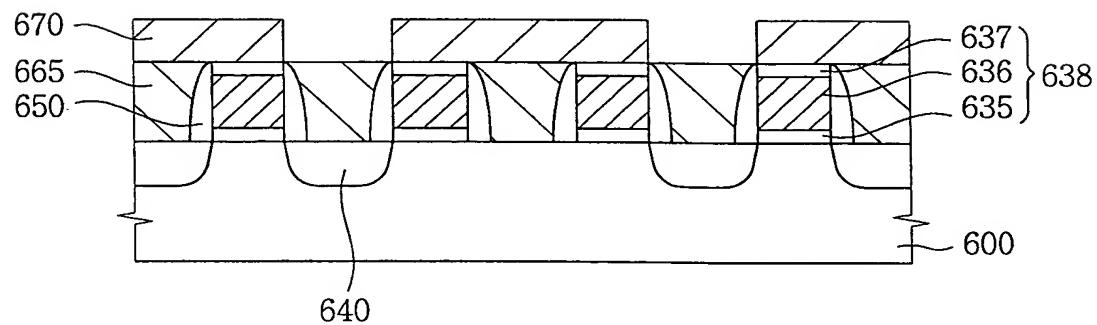


FIG. 6C

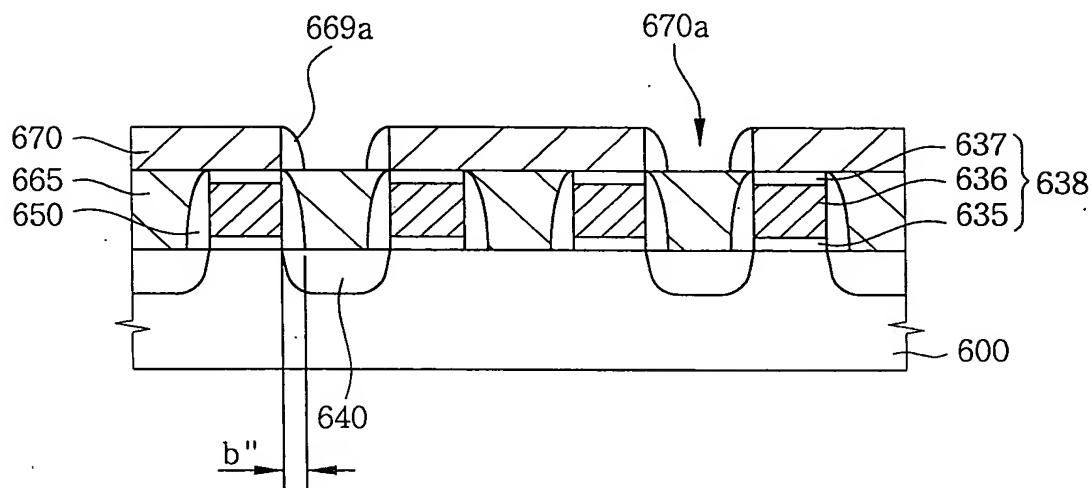


FIG. 6D

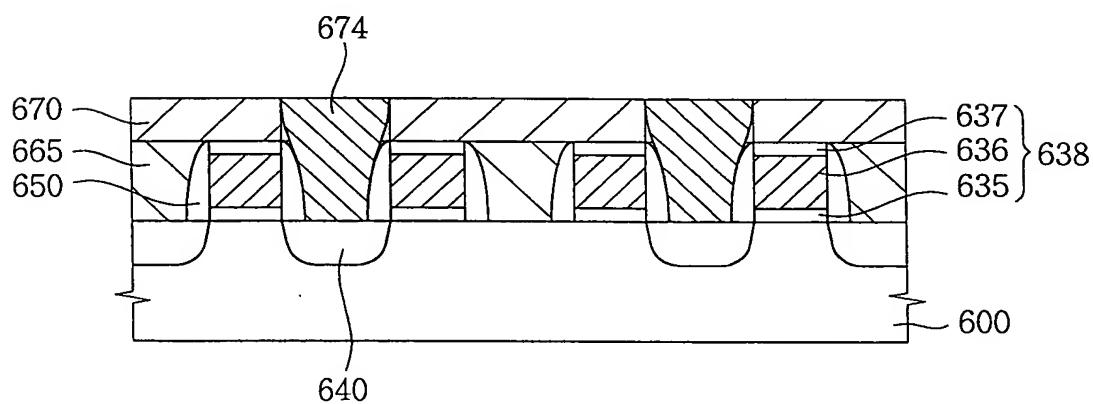


FIG. 7A

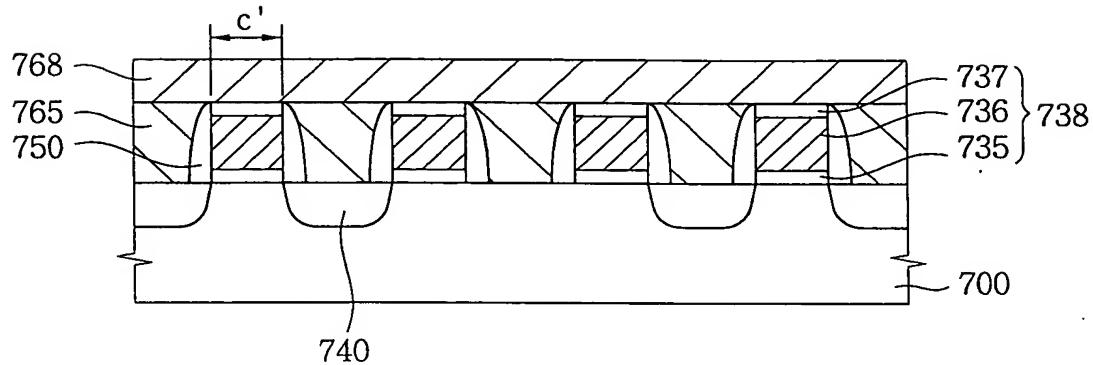


FIG. 7B

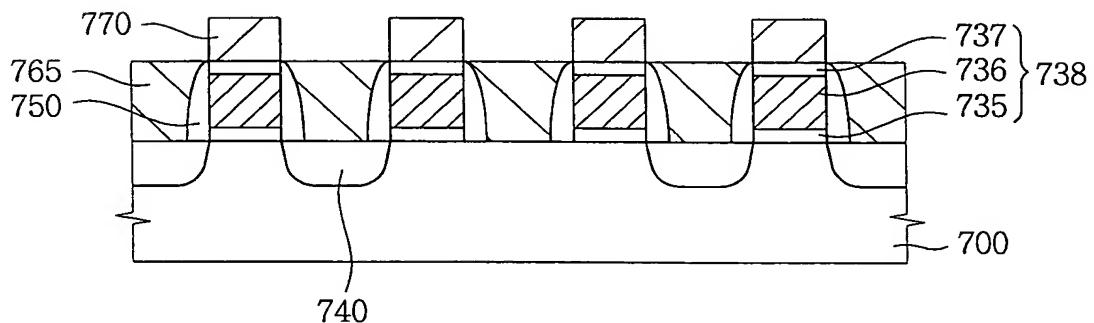


FIG.7C

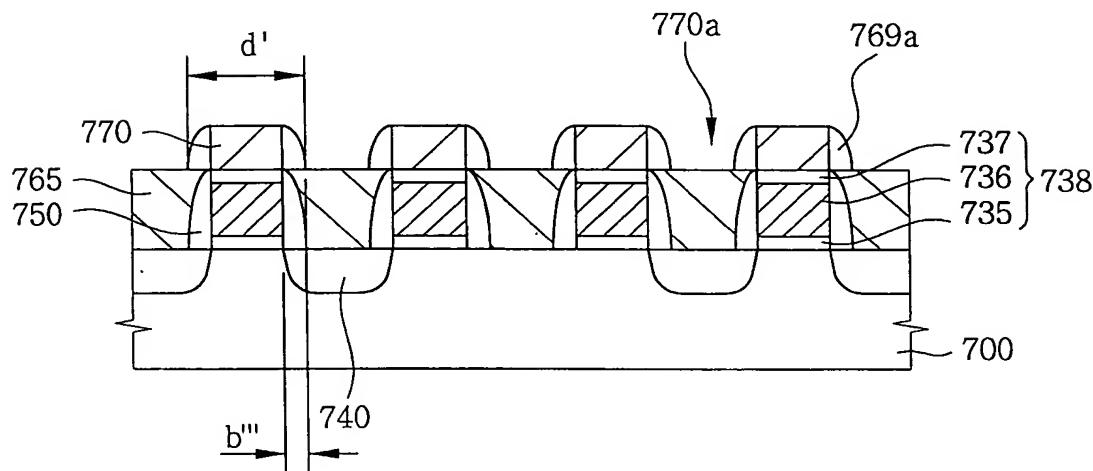
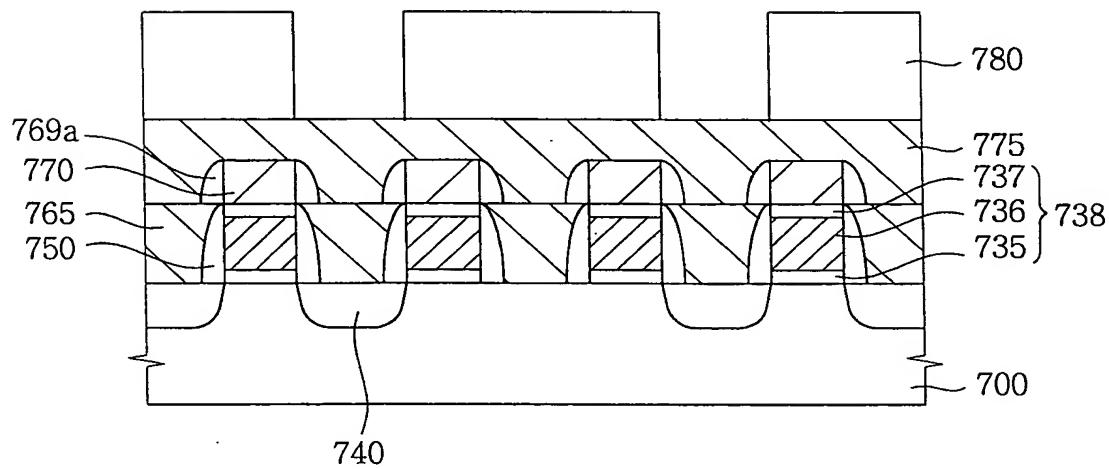


FIG.7D



**METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE**  
Application No. NEW - Attorney Docket No. SEC.1081  
Inventor: Ju-Bum LEE

FIG. 7E

